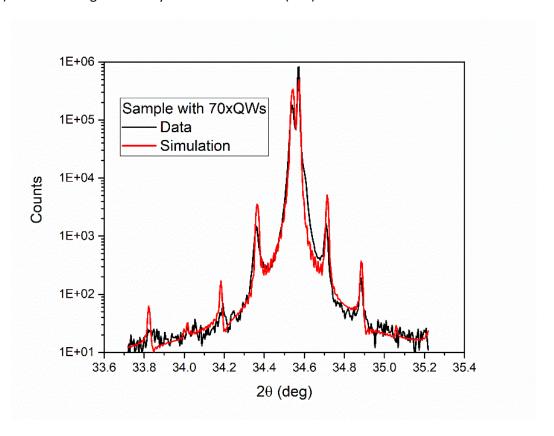
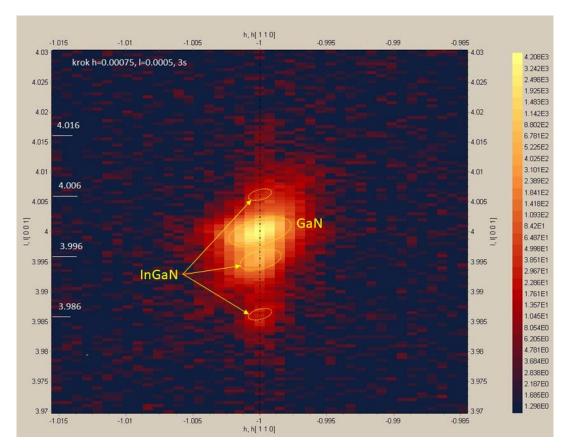
XRD measurement of sample with 70xQWs

1) 2theta-omega scan of symmetric diffraction (002)



- Simulation results:
 - o Periodicity = 6.65 nm
 - o GaN thickness = 5 nm
 - o InGaN thickness = 1.65 nm
 - $In_xGa_{1-x}N$ composition: x = 3.8 %

- 2) Reciprocal space map (RSM) of asymmetric diffraction (-114)
 - GaN and InGaN peaks are vertically correlated (InGaN is fully strained to GaN buffer)
 - No relaxation was observed



 L scan with 3 different configurations, position of InGaN peaks are marked similarly to RSM

